

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No..... 10/099,624
Priority Filing Date..... March 14, 2002
Inventorship..... Brian A. Vaartstra
Assignee..... Micron Technology, Inc.
Priority Group Art Unit..... 1765
Priority Examiner..... R. Kunemund
Attorney's Docket No..... MI22-1830
Title: Aluminum-Containing Material and Atomic Layer Deposition Methods

PRELIMINARY AMENDMENT

To: MS PATENT APPLICATION
Commissioner for Patents and Trademarks
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AMENDMENTS